

| | Search Text |
|---|---|
| 1 | (image graphic\$4) same (profile field frame map\$7 predict\$5 estimat\$4 depict\$5) and (die dice) same (substrate wafer) and (shot) same (substrate wafer) |
| 2 | 1 and contour |
| 3 | 1 and (plac\$7) same (bound\$4 clos\$4 enclos\$4 boundar\$4) |
| 4 | (contour) same (limit\$6 surround\$4 bound\$4 clos\$4 enclos\$4 boundar\$4) same shot same (dice die) |
| 5 | (map\$5 process\$5 predict\$5 estimat\$4 comput\$5 depict\$4) same (graphic\$4 image) same (substrate wafer die dice) |
| 6 | shot and contour and (map\$5 process\$5 predict\$5 estimat\$4 comput\$5 depict\$4) same (graphic\$4 image) same (substrate wafer die dice) |
| 7 | yield and shot and contour and (color grid profile) same (graphic\$4 map\$4) |
| 8 | yield and shot and contour and (color grid profile) same (graphic\$4 map\$4) and (die dice) same (substrate wafer) |